

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/708,424	CHEN ET AL.	
Examiner	Art Unit	
Jeffrey S. Zweizig	2816	

SEARCHED						
Class	Subclass	Date	Examiner			
327	308	2/9/2005	JZ			
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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